

**Notice of References Cited**

Application/Control No.

09/822,037

Applicant(s)/Patent Under  
Reexamination  
WANG, GUANGXIN

Examiner

Harry D Wilkins, III

Art Unit

1742

Page 1 of 2

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-3,791,852 A	02-1974	Bunshah	427/567
	B	US-5,059,297 A	10-1991	Hirao et al	204/290.8
	C	US-5,976,641 A	11-1999	Onishi et al	428/1.3
	D	US-4,595,413 A	06-1986	Hard et al	420/417
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 63-166797 A	07-1988	Japan	Tobioka et al	C30B 29/04
	O	JP 01-290766 A	11-1989	Japan	Sawada et al	C23C 14/34
	P	JP 03-142883 A	06-1991	Japan	Yagi	H01L 29/46
	Q	JP 04-182950 A	06-1992	Japan	Shirosaka et al	G11B 11/10
	R	EP 0 603 486 A2	06-1994	EPO	Muenz	C23C 14/02
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Ohashi et al, "Composition and Structure of Co-Sputtered Ta-Ti Alloy Thin Films", 1972, from Japanese Journal of Applied Physics, vol 11, pages 108-109.
	V	Eck et al, "Properties and production of powder-metallurgical PVD-sources", March 1985, from Erzmetall, Volume 38, Number 3, pages 129-133.
	W	Bugliosi et al, "Performance Evaluation of Innovative PVD Coatings for Different Complex-Shaped HSS Cutting Tools", 1995, from Advances in Inorganic Films and Coatings, pages 573-581.
	X	Heikinheimo et al, "High Temperature Bonding of Alumina based CMC to Metals", 1998, from DVS-Berichte 192, pages 301-304.

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

**Notice of References Cited**

Application/Control No.

09/822,037

Applicant(s)/Patent Under  
Reexamination  
WANG, GUANGXIN

Examiner

Harry D Wilkins, III

Art Unit

1742

Page 2 of 2

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Ludtke et al, "Electron-Beam Physical Vapor Deposition of Microlaminate Composites", March 1999, from EPD Congress 1999, pub by The Minerals, Metals and Materials Society, pages 147-155.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.